

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 021557A	Serial No. New Divisional Appln.
	Applicant(s): Naoya SASHIDA	
	Filing Date: October 31, 2003	Group Art Unit: 2814 (expected)

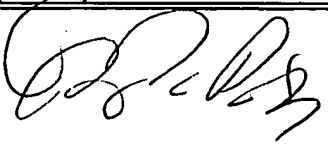
U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclas s	Filing Date (If appropriate)
<u>TS</u>	AA	2002/0006674 A1	Ma et al.	01/17/02	438	3	
<u>TS</u>	AB	6,570,203	Hikosaka et al.	05/2003	257	295	
<u>TS</u>	AC	6,171,970	Xing et al.	01/2001	438	706	
_____	AD						
_____	AE						
_____	AF						
_____	AG						
_____	AH						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
<u>TS</u>	AI	2001-210798	08/03/01	Japan	Abstract
_____	AJ				
_____	AK				

OTHER DOCUMENTS

_____	AL		
_____	AM		
Examiner			Date Considered 7/28/06



INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 021557A	Serial No. 10/697,944
	Applicant(s): SASHIDA, Naoya	
	Filing Date: October 31, 2003	Group Art Unit: 2811

U.S. PATENT DOCUMENTS

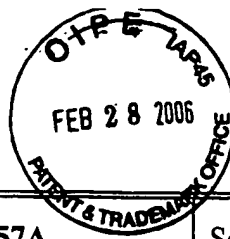
Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
<u>TJ</u>	AA	6,121,648	Evans, Jr.	9/19/00	257	295
<u>TJ</u>	AB	6,201,271	Okutoh et al.	3/13/01	257	295
<u>TJ</u>	AC	2002/0021544	Cho et al.	2/21/02	361	200
<u>TJ</u>	AD	6,211,035	Moise et al.	4/3/01	438	396
<u>TJ</u>	AE	2002/0127867	Lee	9/12/02	438	694

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
<u>TJ</u> AF AG AH	EP 1 189 262 A2	3/20/02	European Yes

OTHER DOCUMENTS

<u>TJ</u>	AI	SAKODA T. ET AL: "HYDROGEN-ROBUST SUBMICRON IROX/PB (ZR,TI) 03/IR CAPACITORS FOR EMBEDDED FERROELECTRIC MEMORY" JAPANESE JOURNAL OF APPLIED PHYSICS, PUBLICATION OFFICE JAPANESE JOURNAL OF APPLIED PHYSICS. TOKYO, JP, vol. 40, no. 4B, PART 1, April 2001 (2001-04), pages 2911-2916, XPO01081007 ISSN: 0021-4922 *the whole document*.
<u>TJ</u>	AJ	NAKURA T. ET AL: "A hydrogen-barrier interlayer dielectric with a SiO ₂ /SiON/SiO ₂ stacked film for logic-embedded FeRAMs" ELECTRON DEVICES MEETING, 1999. IEDM TECHNICAL DIGEST. INTERNATIONAL WASHINGTON, DC, USA 5-8 DEC. 1999, PISCATAWAY, NJ, USA, IEEE, US, 5 December 1999 (1999-12-05), pages 801-804, XP010372095 ISBN: 0-7803-5410-9 *the whole document*.
<u>TJ</u>	AK	Partial European Search Report dated 10/24/05.
Examiner		Date Considered 4/26/08



INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 021557A	Serial No. 10/697,944
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	Filing Date: October 31, 2003	Group Art Unit: 2811

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Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
<u>TD</u>	AA	6,509,601	Lee et al.	1/21/03	257	310	
	AB						
	AC						
	AD						
	AE						

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		Document No.	Date	Country	Translation (Yes or No)
<u>TD</u>	AF	2001-111007	4/20/01	Japan	No
	AG				
	AH				
	AI				
	AJ				

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<u>TD</u>	AK	Japanese Office Action dated 2/7/06.
	AL	
Examiner	<u>David Long</u>	Date Considered <u>4/28/06</u>

INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 021557A	Serial No. 10/697,944
	Applicant(s): SASHIDA, Naoya	
	Filing Date: October 31, 2003	Group Art Unit: 2811

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
<u>JS</u>	AA					
_____	AB					
_____	AC					
_____	AD					
_____	AE					

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Document No.	Date	Country	Translation (Yes or No)		
<u>72</u>	AF	EP 1 077 483 A	2/21/01	Europe	Yes
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_____	AI				
_____	AJ				

OTHER DOCUMENTS

<u>JS</u>	AK	European Search Report of 3/27/06.
_____	AL	
Examiner <u>JS</u>	Date Considered	4/27/06